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REPLY UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2142

PATENT  
5181-83600/P5882

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 09/842,531

Filed: April 25, 2001

Inventor:

Hyon T. Kim

*12/01/05*  
Title: Maintaining Fabric Device  
Configuration Through  
Dynamic Reconfiguration

§ Examiner: Nguyen, Hai V.  
§ Group/Art Unit: 2142  
§ Atty. Dkt. No: 5181-83600

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

Robert C. Kowert

Printed Name

November 10, 2005  
Date

RESPONSE TO FINAL ACTION OF SEPTEMBER 15, 2005

*Please Enter IT*  
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Commissioner for Patents  
P.O. Box 1450  
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Dear Sir:

This paper is submitted in response to the Final Action of September 15, 2005, to further highlight why the application is in condition for allowance.